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TITLE: Method and apparatus for investigating a sample  
under tension  
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,356/32 ,356/634 ,73/826

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PARENT-CASE:  
BACKGROUND OF THE INVENTION This application is a  
continuation-in-part  
application of the U.S. application Ser. No. 746,096.

FOREIGN-APPL-PRIORITY-DATA:  
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BSPR:  
German Auslegeschrift No. 26 31 663 teaches the zero  
contact measurement of  
relative changes in length of a sample on the basis of  
comparative measurements  
of travel time of laser reflections during continuous  
scanning of the total  
measured length of the sample, whereby a light beam is  
split by a beam  
splitter, with one portion of the beam of light being  
directed to the sample  
and then detected by a photodetector, and the other portion  
of the beam  
directed by an adjustable reference diaphragm to a second  
similar  
photodetector. Repeated scanning of the zone of different  
reflectivity of the  
object being measured is required for evaluation in order  
to obtain any  
measurement results at all. For this reason, the method  
does not exhibit  
sufficient time resolution and, in particular, does not  
permit immediate

detection of rapid sudden changes in length, so that this method, too, cannot be used for rapid pulling or tearing tests. Moreover, the method allows determination of only an average change in length over the total measurement area, and not different stretching behavior in different areas of the sample, especially not the three-dimensional distribution of stretching over the sample, something which is important because a sample is not necessarily subjected to equal changes in length in all of its areas when the same tensile stress is applied, but can exhibit different distributions.

**BSPR:**

A zero-contact optical measuring method using a cathetometer is described in "Messtechnische Briefe" Vol. 13 No. 2, Page 25-31, 1977 wherein markings made on the samples are scanned with the aid of an optical aiming device by the operator and the distances between the markings are measured by a linear measurement system built into the cathetometer. This is a subjective measuring method involving observation, with the adjustments being made by the operator on the basis of the observation possibly being further automatically processed. The subjective decision on the part of the operator is involved in the measuring process. In addition, the known method does not permit any dynamic pulling tests but only creep tests. In addition, only measurements of lengthwise stretching can be conducted.

**DEPR:**

According to the invention an apparatus is provided which includes a housing 1 accommodating an illuminating device 2 comprising, for example an ellipsoid lamp 3, a diaphragm 4, preferably with a volume scattering disk, a lens 6, and an exit diaphragm 7. A receiving unit 11 with a shading

diaphragm, a focusing lens 12, and a photodiode 13 mounted on a holder are disposed outside of the housing 1 at a distance therefrom on the optical axis determined by the illuminating device 2. The sample under tension 21 is placed between illuminating device 2 and receiving unit 11.

DEPR:

In the given arrangement, the cylindrical lens also causes the light beam to be guided during the scanning produced by the rotating mirror so to speak parallel to itself over the sample under tension beneath the pattern mounted on it.

Laser beam 33 is reflected from the pulling sample 21.

Accordingly, an additional receiving device 38 is provided in the housing, which has among

other things a lens 41 as well as a photodiode 39. The signals detected by the two photodiodes 13 and 39 are fed to an electronic circuit 51 where they are

processed in a manner to be described hereinbelow. The light from lamp 3 is

diffusely scattered by a volume-scattering disk 14 in such fashion that the

intensity of the light illuminating sample 21 is largely homogeneous, in other

words every point on the sample is illuminated in the lengthwise and transverse

directions with essentially the same light intensity in order to obtain a

signal which is as linear as possible. Double diaphragm 4 is associated

directly with scattering disk 14, with the diaphragm 4 including two diaphragm

slits 16, through which the light from lamp 3 is broken into two partial bands,

which are rendered parallel by lens 6, whereby the edges of the light beams can

be blocked out by additional diaphragm 7. Accordingly, two light bands 17

(FIG. 3) fall on sample 21 and the shading diaphragm 18 located located

directly behind the sample 21. As can be seen from FIG. 3

in particular, the amount of light from the two light bands 17 which passes between sample 21 and shading diaphragm 18 is linearly dependent on the width of the sample, which contracts when the sample is subjected to transverse tension. Calibration can be done if shading diaphragm 18 is adjustable and sample 21 is so adjusted in the relaxed state that no light falls between shading diaphragm 18 and sample 21. The amount of light that passes between sample 21 and shading diaphragm 18 during tension is focused by a focusing lens 12 on photodiode 13 and initially converted into a current which is proportional to the light intensity. The photodiode is biased in the blocking direction whereby the barrier capacitance is simultaneously reduced making possible a more rapid response. By connecting a resistance in series with a photodiode, the photocurrent is converted into a decreasing proportional voltage through the resistor, whereby the value of the resistor determines the sensitivity of the arrangement. The additional electronic circuit initially essentially includes an amplifier and an electrometer subtractor for zero balancing to exclude ambient light.

#### DEPR:

The pulling device, not shown in greater detail, comprises clamping devices 23 for firmly clamping the sample 21. The sample 21 (FIG. 5a) comprises a central part 24 and gripping parts or shoulders 26 which are broadened at both ends thereof, to which shoulders the clamping devices 23 are attached. In addition, a transverse pattern 27 with a different absorptivity and therefore reflectivity or scattering power similar to a bar code, is mounted on one side of the sample 21 in middle part 24. A transverse pattern 27 can be printed, for example, by

screen printing. The sample itself consists of any material whose longitudinal stretching in a stretching test is to be investigated, especially in a rapid tearing test. The sample 21 is pulled apart in such a test by a pulling device equipped with clamping devices 23 in the direction of arrow F. It is evident from a comparison between FIG. 5a and FIG. 5 that the pattern segments increase their spacing as the sample is pulled whereby the frequency of the intensity, modulated by pattern 27, of the reflected light is changed by a beam that uniformly scans the sample, i.e. with constant scanning frequency.

CLPR:

17. An apparatus for measuring a lateral contraction of a test piece having a transverse pattern with a reflectivity differing from the test piece elongated by a drawing device including a device for measuring a lateral contraction of the test piece, the apparatus comprising a light source means arranged upstream of the test piece, said light source means including imaging optic means, a diaphragm plate means disposed downstream of the test piece for defining a narrow strip of light from the light source means, and a light detector means positioned downstream of the diaphragm and disposed on an optical axis defined by the light source means, the imaging optic means, and the test piece.